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Confirmation Letter

To,
K. S. Thakare
Published in : Volume 7 | Issue 11 | 2020-11-19



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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Authors : K. S. Thakare, S. J. Patil, R. R. Ahire

Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.

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